



## INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

ATTY DOCKET NO.

ITL1023US (P16710)

SERIAL NO.

10/679,816

APPLICANT(S):

ROBERT BRISTOL ET AL.

FILING DATE:

October 6, 2003

GROUP ART UNIT:

1756

## U.S. PATENT DOCUMENTS

INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
KAT	A.	5,158,861	10/27/1992	TOKUI ET AL.	430	325	
	B.						
	C.						
	D.						
	E.						
	F.						
	G.						
	H.						
	I.						

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	J.							
	K.							
	L.							
	M.							
	N.							
	O.							
	P.							

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

KAT	Q.	Cheng et al., "Improving Resist Resolution and Sensitivity Via Electric-Field Enhanced Postexposure Baking", J. Vac. Sci. Technol. B 20(2), Mar/Apr 2002
	R.	
	S.	
	T.	
	U.	
	V.	
	W.	

EXAMINER

K. Duda

DATE CONSIDERED

3-6-06

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)				ATTY DOCKET NO. ITL 1023US (P16710)		SERIAL NO. 10/679,816	
				APPLICANT(S): Robert Bristol et al.			
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U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
UAD	A.	5,648,000	07/15/1997	Yamazaki et al.	—	—	
UAD	B.	5,783,362	07/21/1998	Wakiya et al.	—	—	
UAD	C.	6,103,145	08/15/2000	Angelopoulos et al.	—	—	
	D.						
	E.						

U.S. PATENT APPLICATION PUBLICATIONS							
UAD	F.	2002/0046703	04/25/2002	Templeton	—	—	
UAD	G.	2003/0008246	01/09/2003	Cheng et al.	—	—	
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	I.						
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FOREIGN PATENT DOCUMENTS								
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
UAD	K.	JP 57-32632	02/22/1982	Japan	—	—	Abstract Only	
UAD	L.	JP 63-71842	04/01/1988	Japan	—	—	Abstract Only	
UAD	M.	JP 63-244622	10/12/1988	Japan	—	—	Abstract Only	
UAD	N.	JP 10-106930	04/24/1998	Japan	—	—	Abstract Only	
	O.							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		
	P.	
	Q.	
	R.	
	S.	
	T.	
	U.	
	V.	

EXAMINER <i>K. Duda</i>	DATE CONSIDERED <i>3-6-06</i>
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